



Prof. Dr.-Ing. Jörg Franke

**Institute for Factory Automation  
and Production Systems**

Friedrich-Alexander University Erlangen-Nuremberg

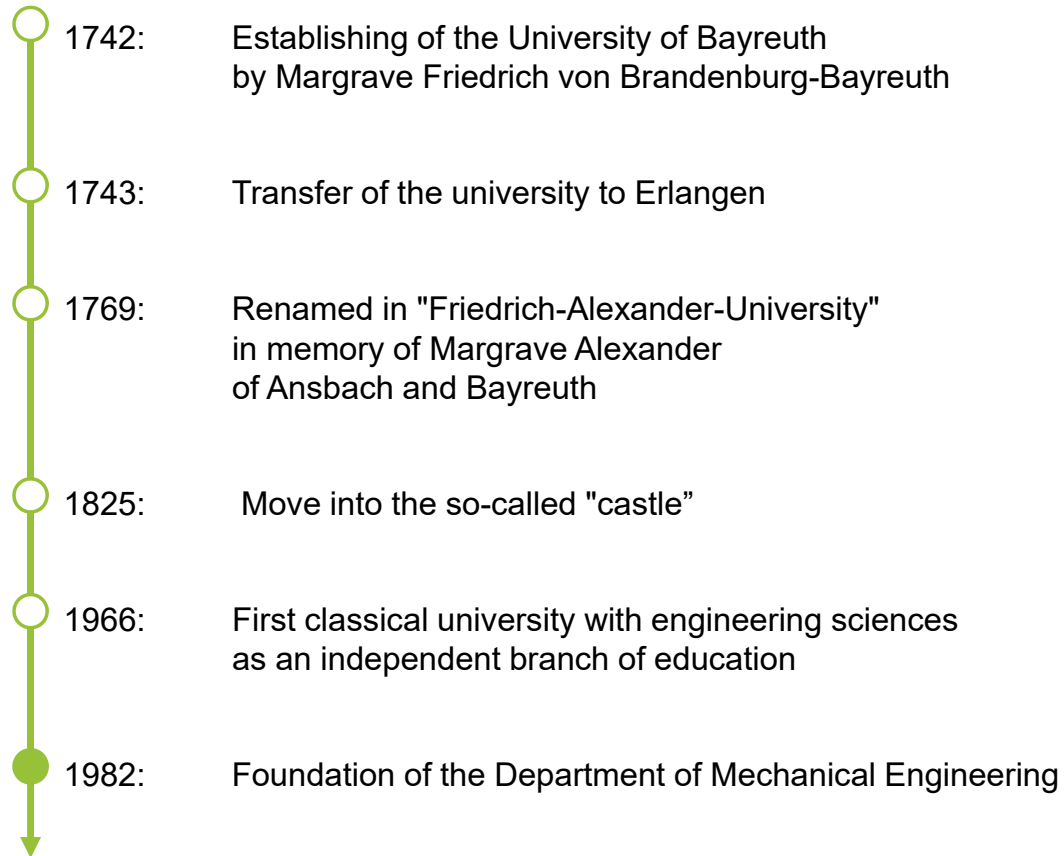


**Friedrich-Alexander-Universität**  
Technische Fakultät

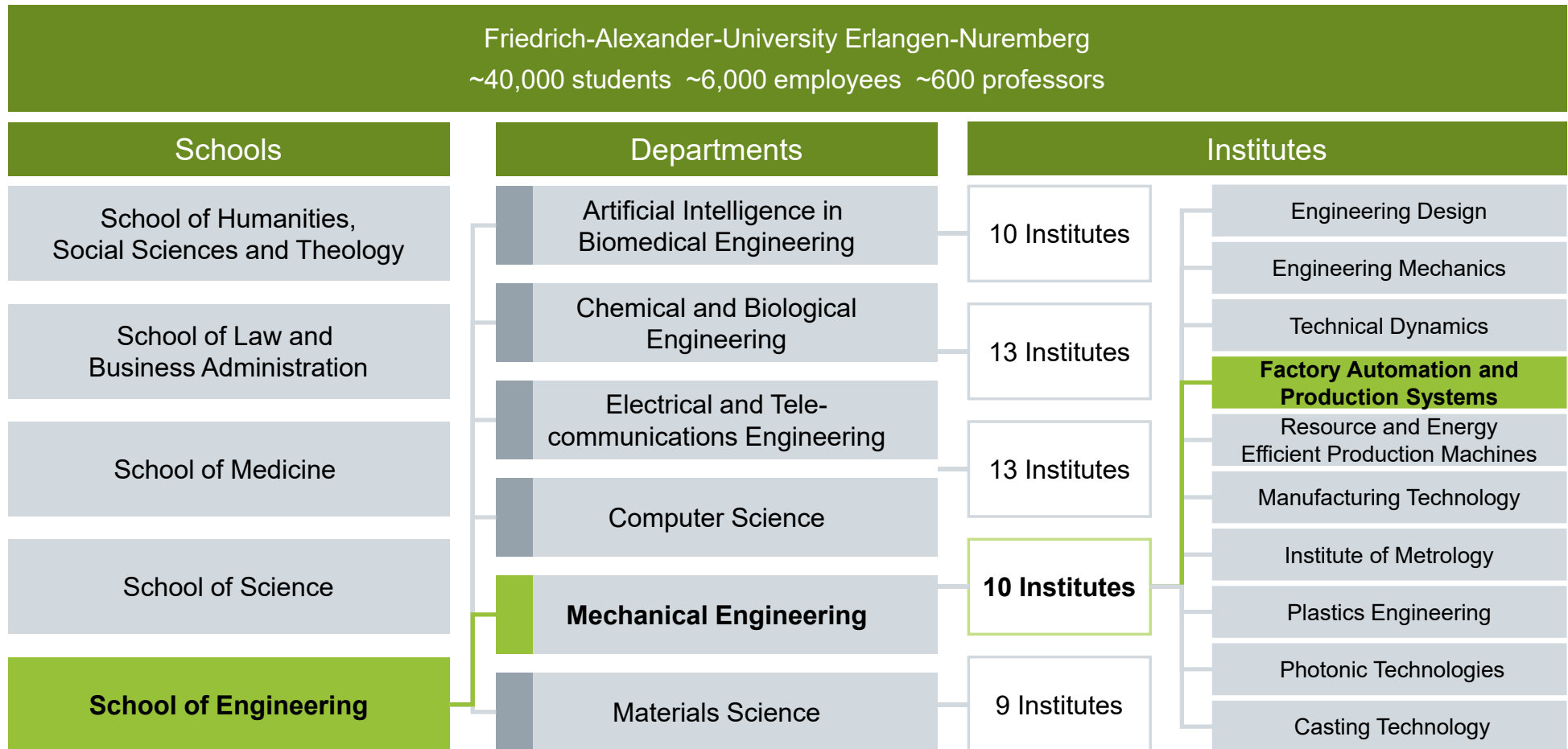
## **Presentation of the Institute FAPS**

Electronics Production

## 275 years of university history form the foundation for our success today



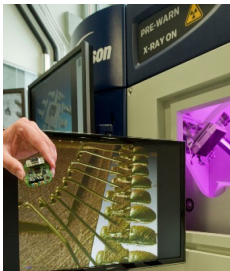
## The School of Engineering of the University of Erlangen-Nuremberg is structured in five departments of different disciplines.



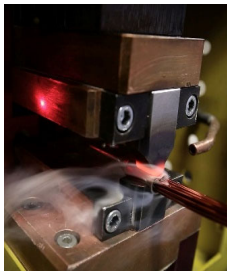


**The Institute for Factory Automation and Production Systems (FAPS)  
is researching the production and assembly of mechatronic products.**

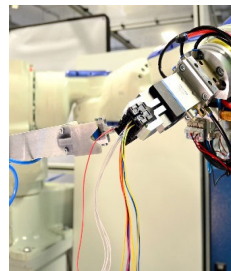
Electronics  
Production



Electro-  
mechanical  
Engineering



Signal and  
Power  
Networks



Home  
Automation



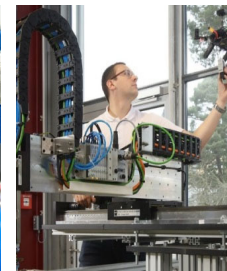
Medical  
Technology



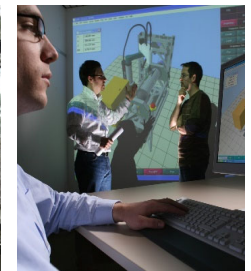
Robotics



Automation  
Technology



Engineering  
Systems

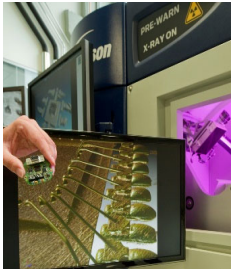
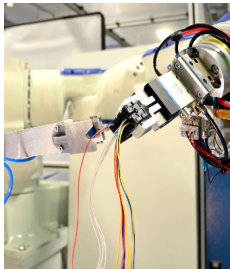
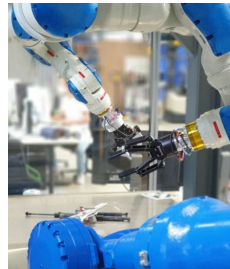
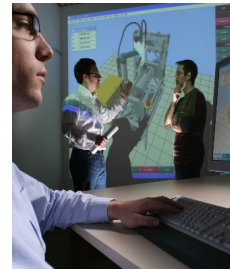


Auf AEG Nuremberg



Technical Faculty Erlangen

## The Institute for Factory Automation and Production Systems (FAPS) is researching the production and assembly of mechatronic products.

| Electronics Production                                                                                                                                                                                                                                                                                                                     | Electro-mechanical Engineering                                                                                                                                                                                                                                                                                         | Wiring Systems                                                                                                                                                                                                                                                                                                      | Home Automation                                                                                                                                                                                                                                                                                                                | Medical Technology                                                                                                                                                                                                                                                                                          | Robotics                                                                                                                                                                                                                                                                                                                                                  | Automated Production Systems                                                                                                                                                                                                                                                                                                                                | Engineering Systems                                                                                                                                                                                                                                                                                                                                 |
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|                                                                                                                                                                                                                                                           |                                                                                                                                                                                                                                       |                                                                                                                                                                                                                                    |                                                                                                                                                                                                                                              |                                                                                                                                                                                                                          |                                                                                                                                                                                                                                                                        |                                                                                                                                                                                                                                                                          |                                                                                                                                                                                                                                                                  |
| <ul style="list-style-type: none"> <li>■ Flexible printed circuits</li> <li>■ 3-D MID</li> <li>■ SMT-assembly</li> <li>■ Optoelectronic AVT</li> <li>■ Power electronics</li> <li>■ Quality assurance/Reliability tests</li> <li>■ Structuring</li> <li>■ Printed electronics</li> <li>■ Additive manufacturing of mechatronics</li> </ul> | <ul style="list-style-type: none"> <li>■ Laser cutting</li> <li>■ Joining laminated core</li> <li>■ Magnet manufacturing, assembly, testing</li> <li>■ Winding technologies</li> <li>■ Impregnating</li> <li>■ Grouting</li> <li>■ Circuitry</li> <li>■ Test technologies</li> <li>■ Additive Manufacturing</li> </ul> | <ul style="list-style-type: none"> <li>■ New topologies in Wiring systems</li> <li>■ Wire harness CAD</li> <li>■ Assembly and interconnection technologies</li> <li>■ 3D-MID antennas</li> <li>■ Automated assembly of wire harness</li> <li>■ Testing systems</li> <li>■ Assembly of control enclosures</li> </ul> | <ul style="list-style-type: none"> <li>■ Home automation</li> <li>■ Energy-management</li> <li>■ Comfort &amp; safety</li> <li>■ Communication and Infotainment</li> <li>■ Decentralized energy production /storage</li> <li>■ Intelligent, efficient heating systems</li> <li>■ Synergy of mobility and smart home</li> </ul> | <ul style="list-style-type: none"> <li>■ (Partly) autonomous assistance systems</li> <li>■ Mechatronic implants</li> <li>■ Automation of medical diagnostics</li> <li>■ Digitalization in medical technology</li> <li>■ Compatible sensors and actuators</li> <li>■ Individualized manufacturing</li> </ul> | <ul style="list-style-type: none"> <li>■ Sensors for detecting the environment and for interaction</li> <li>■ New kinematics and drives</li> <li>■ Safe control architectures</li> <li>■ Learning systems for control, navigation and interaction</li> <li>■ Industrial and service robots</li> <li>■ Personal robots</li> <li>■ Mobile Robots</li> </ul> | <ul style="list-style-type: none"> <li>■ Industrial Smart Services</li> <li>■ Service-oriented architectures</li> <li>■ Condition and process monitoring</li> <li>■ Semantic technologies for machine interaction</li> <li>■ Cloud-based platform solutions</li> <li>■ Communication technologies</li> <li>■ Data Analytics and Machine Learning</li> </ul> | <ul style="list-style-type: none"> <li>■ Integrated Engineering</li> <li>■ Planning of production systems and intralogistics</li> <li>■ Development of digital process chains</li> <li>■ Process automation in engineering</li> <li>■ Engineering of resource-efficient production systems</li> <li>■ Human-Machine-Interaction (VR, AR)</li> </ul> |



**Technology fields ensure an exchange of knowledge across research areas and promote specific technologies.**



## **FAPS: The competent institute in automation technology and mechatronic systems.**

### **VISION**

**FAPS is a recognized institute for teaching and research in the area of automation and mechatronic systems, with a interdisciplinary development of holistic optimization to serve the welfare of the people.**

### **MISSION**

FAPS creates innovations through the integration of knowledge from various disciplines, in particular

- the specialized disciplines in mechanical, electric/electronics, information technology, bionics and optics;
- levels of integration from the components to the system;
- automation components such as controllers, sensors and actuators;
- the entire product life cycle, from concepts, through to development, production, use and recycling;
- through university research and teaching, industry collaboration, technology transfer and the founding of new companies;
- through the human-machine interaction;
- through sustainable and efficient methods of production, distribution, usage, storage and reuse of resources.

## All employees set out on their activities based on commonly shared values at FAPS.

### Responsibility

We work on tasks including research and teaching, which are the result of high-quality scientific practices. The aim of our work is to ensure value and to expand job opportunities in Germany.

### Cooperation

Honesty, reliability and fairness are fundamental pillars of an effective collaboration with colleagues, industry partners and students. Such principles form the basis of proficiency, punctuality and open communication.

### Future orientation

We continuously confront new multidisciplinary topics, and accordingly, develop relevant initiatives, ideas, and scopes developments in research and teaching. We give ourselves sufficient freedom for this.

### Quality

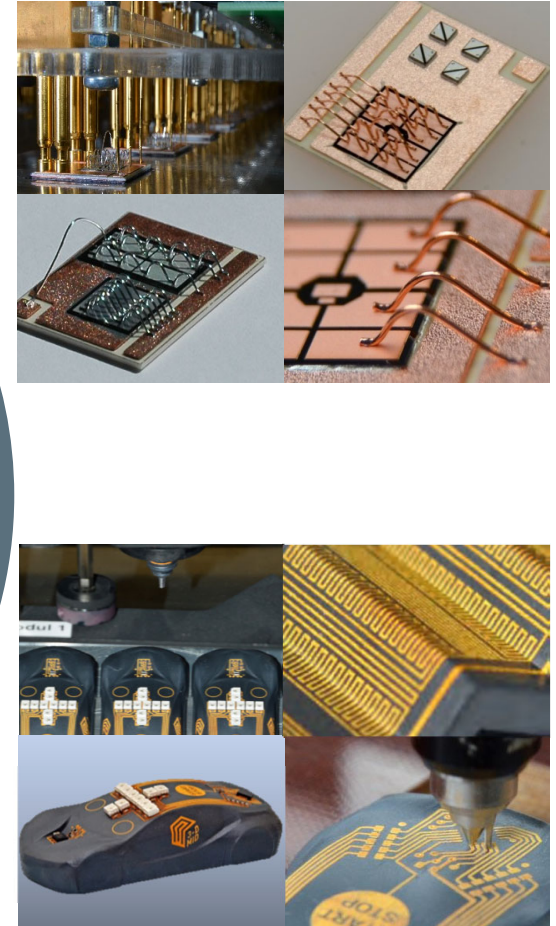
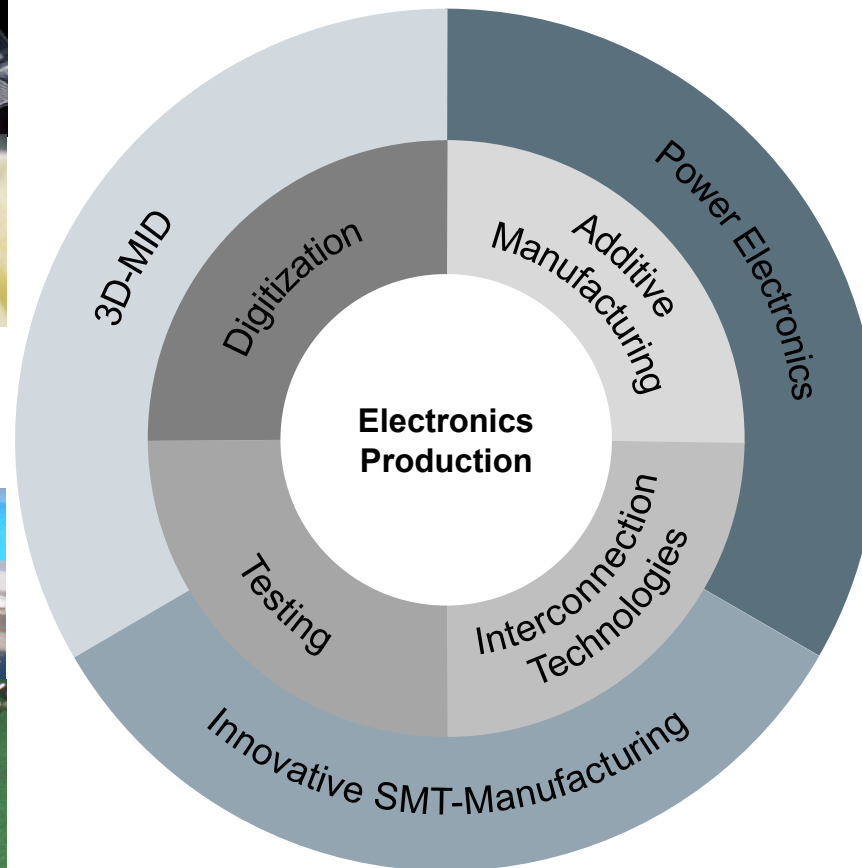
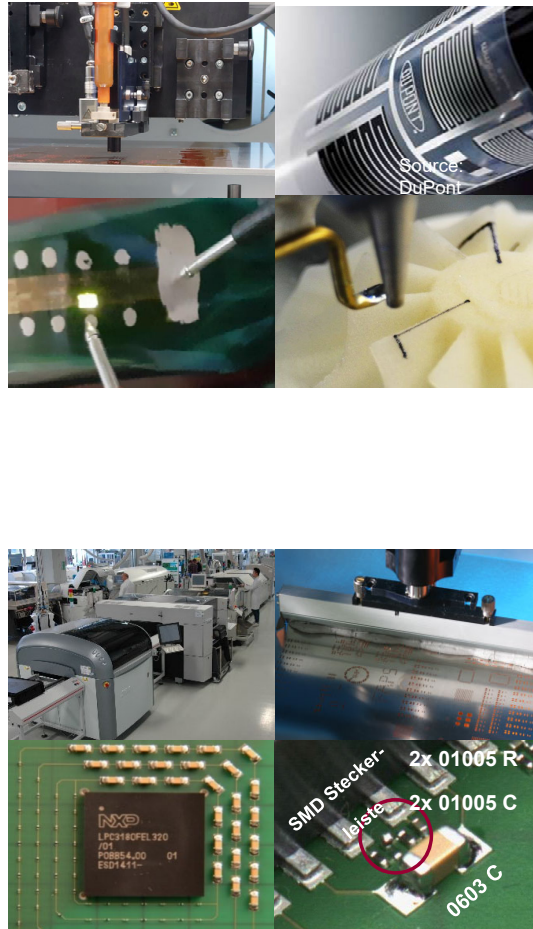
The fruit of our labour is the result of high-quality work, which is carefully prepared and presented.

### Embodiment

We define ourselves with goals and research fields of the institute.



The Research Sector Electronics Production focuses in three Core-Teams current challenges and new approaches for manufacturing mechatronic devices.



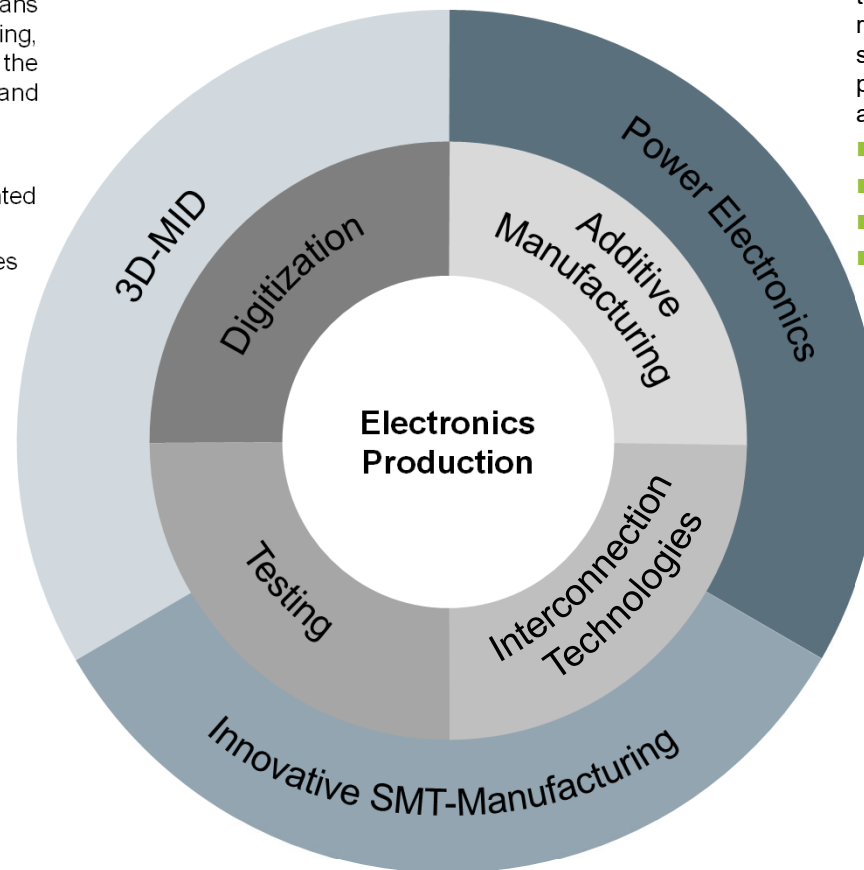
## The Research Sector Electronics Production focuses in three Core-Teams current challenges and new approaches for manufacturing mechatronic devices.

Spatial circuit carriers offer potential for highly integrated and miniaturized assemblies. By means of modern processes such as AerosolJet printing, LDS or FDM printing, both the substrates and the circuit layout can be structured efficiently and flexibly

- Highly flexible structuring
- Mounting and connection technology for printed electronics
- Sensor technology through printing processes
- AI in printed electronics

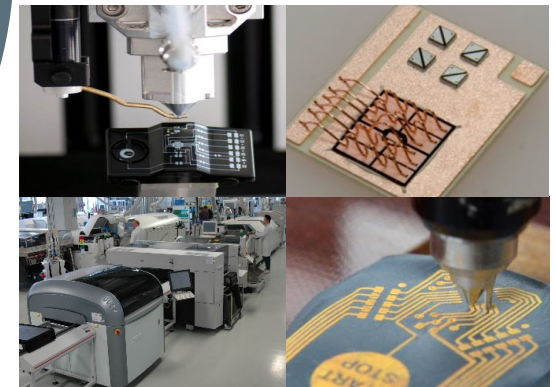
A high degree of automation and yield in conventional electronic module assembly require alternative interconnection technologies, simulation-based predictions for design rules and data-driven methods to realize further optimization.

- Optimized quality control using data-driven analysis methods
- Development of AI-based low-cost automation solutions for SMT/THT.
- Simulation-based design for manufacturing in the field of production of electronic modules



A high-performance assembly and connection technology is essential to meet the increasing requirements in terms of efficiency, reliability and service life. The use of additive manufacturing processes and materials makes it possible to address these trends.

- Substrate production via additive processes
- Bottom-Level Interconnection
- Top-Level Interconnection
- Testing technology



With data driven methods, flexible processes and improved quality control, FAPS investigates further advances in the already well-established manufacturing of 2D electronic assemblies.

## Technologies

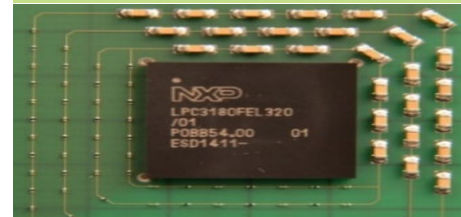
### SMT



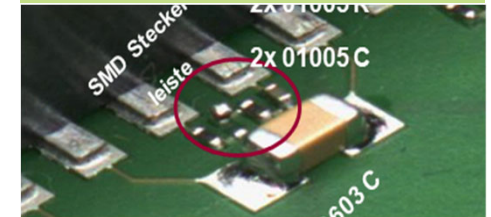
### THT Wave Soldering



### Alternative connection technologies



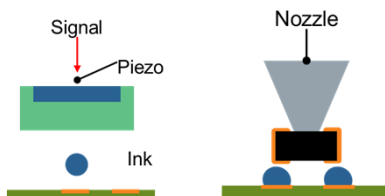
### Testing Technologies



## Methods

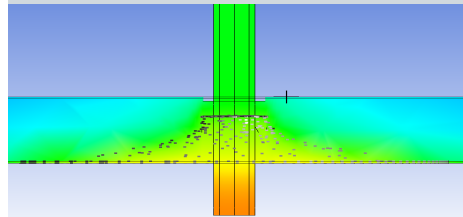
### Design of Experiments

- Design for Manufacturing
- Process development
- Process optimization



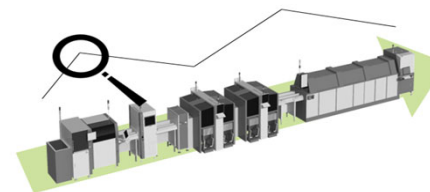
### Simulation & Machine Learning

- Fluid dynamics
- High performance computing
- Computer Vision



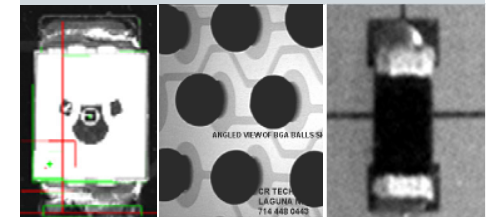
### IIoT infrastructure

- Traceability
- Cloud-/Edge connectivity
- Automated data preparation



### Production and testing systems

- Matrix production
- Test plan optimization
- Advanced quality control





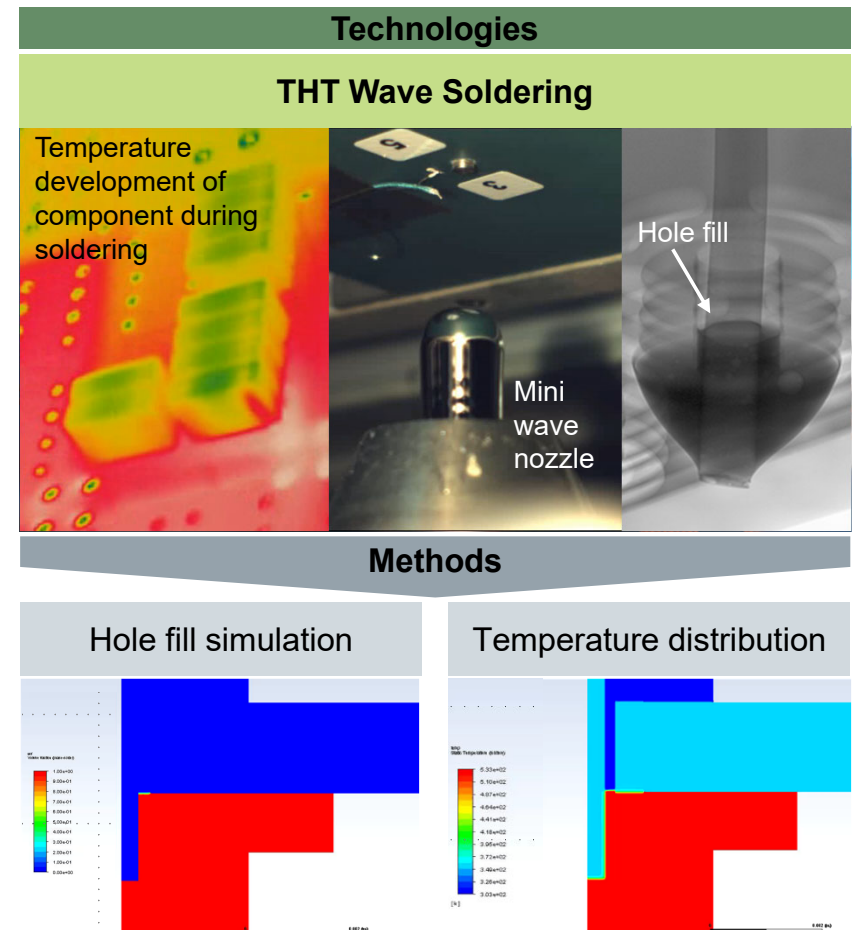
# Fluidsimulation of hole fill in selective wave soldering allows accurate quality prediction and design for manufacturing (DfM).

## Motivation & Objective

- Hole fill is the critical quality criterion in THT soldering
- Hole fill is primarily impacted by the solder joint copper layer design
- DfM requires reliable models to prevent manufacturing problems

## Method

- Parametric definition of copper layer design
- Temperature dependent solder alloy material model
- CFD ANSYS Fluent with volume of fluid model (VOF) for hole fill calculation
- Prediction error ~10-15%



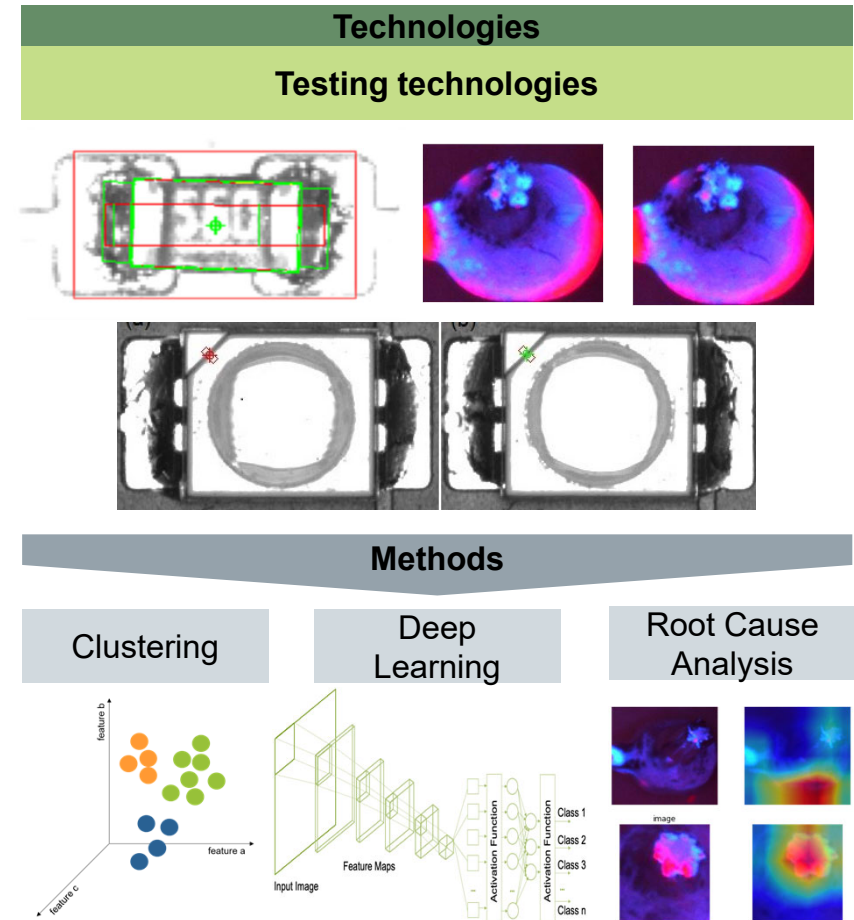
**False calls of solder joints are a challenge in both SMT and THT manufacturing, which are addressed by a combination of multiple Machine Learning approaches.**

### Motivation & Objective

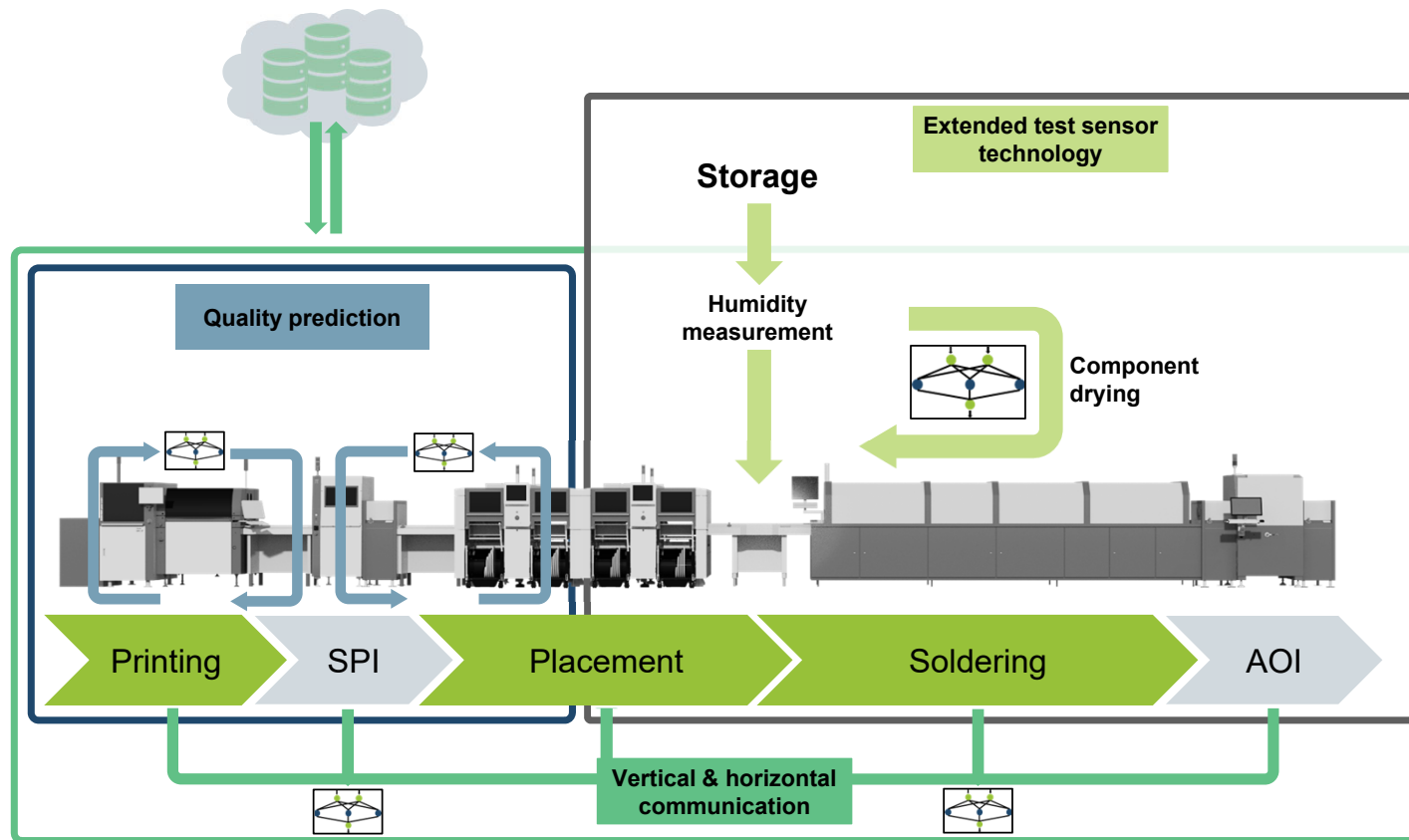
- False calls during quality control lead to additional manual inspection and unnecessary scrap.
- Accurate identification is necessary to prevent error slip.
- Ratio between false calls and true defects depends on technologies (SMT/THT), product and adjustment of conventional test routine.
- State-of-the-art Automated Optical Inspection machines need high investments.

### Method

- Low cost camera systems to detect potential defects in early production stages
- Clustering data and AI-based classification and one-class-learning to identify either good solder joints and components, false calls or defects
- Enhancing datasets by generation of synthetic images of defects



By using AI in SMT manufacturing, measurement data from individual control loops can contribute to process and quality improvement across machines and lines.



### Enhanced sensor systems

- Humidity measurements for components by new sensor systems
- Integration of new sensor data to existing information

### Quality prediction & control

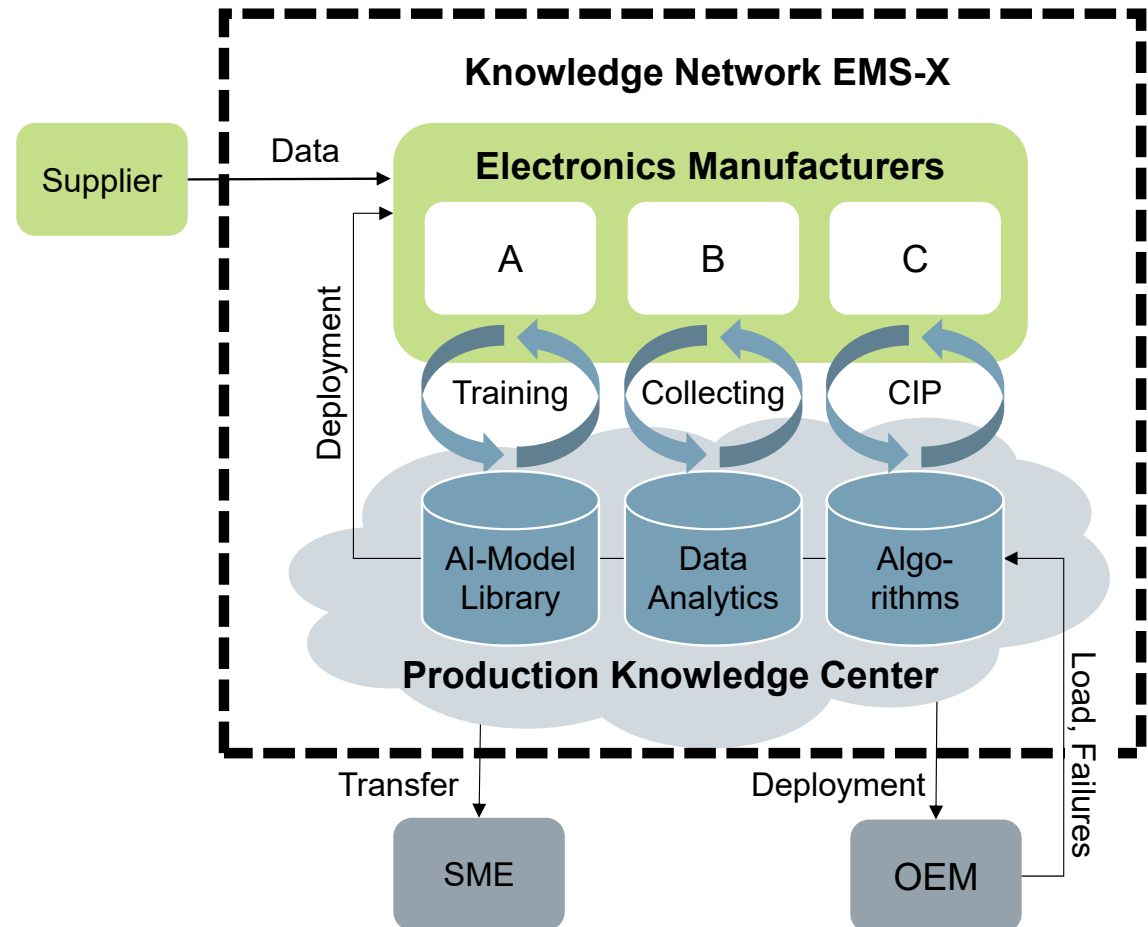
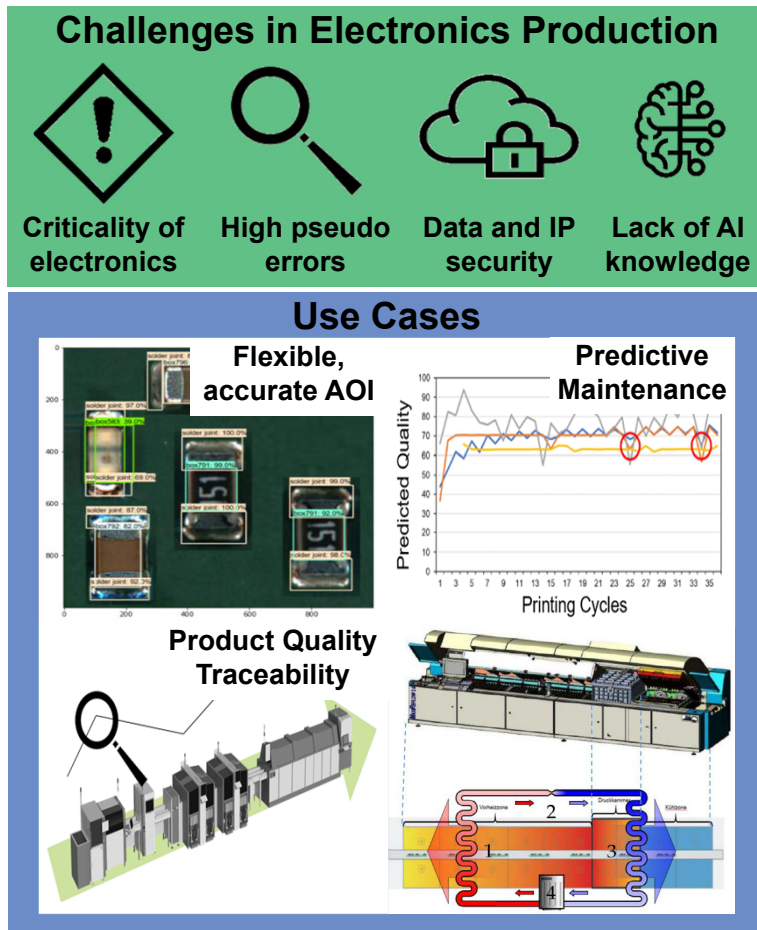
- Linking quality prediction and need for maintenance and adjustment
- Quality control to reduce manual inspection

### Vertical & horizontal communication

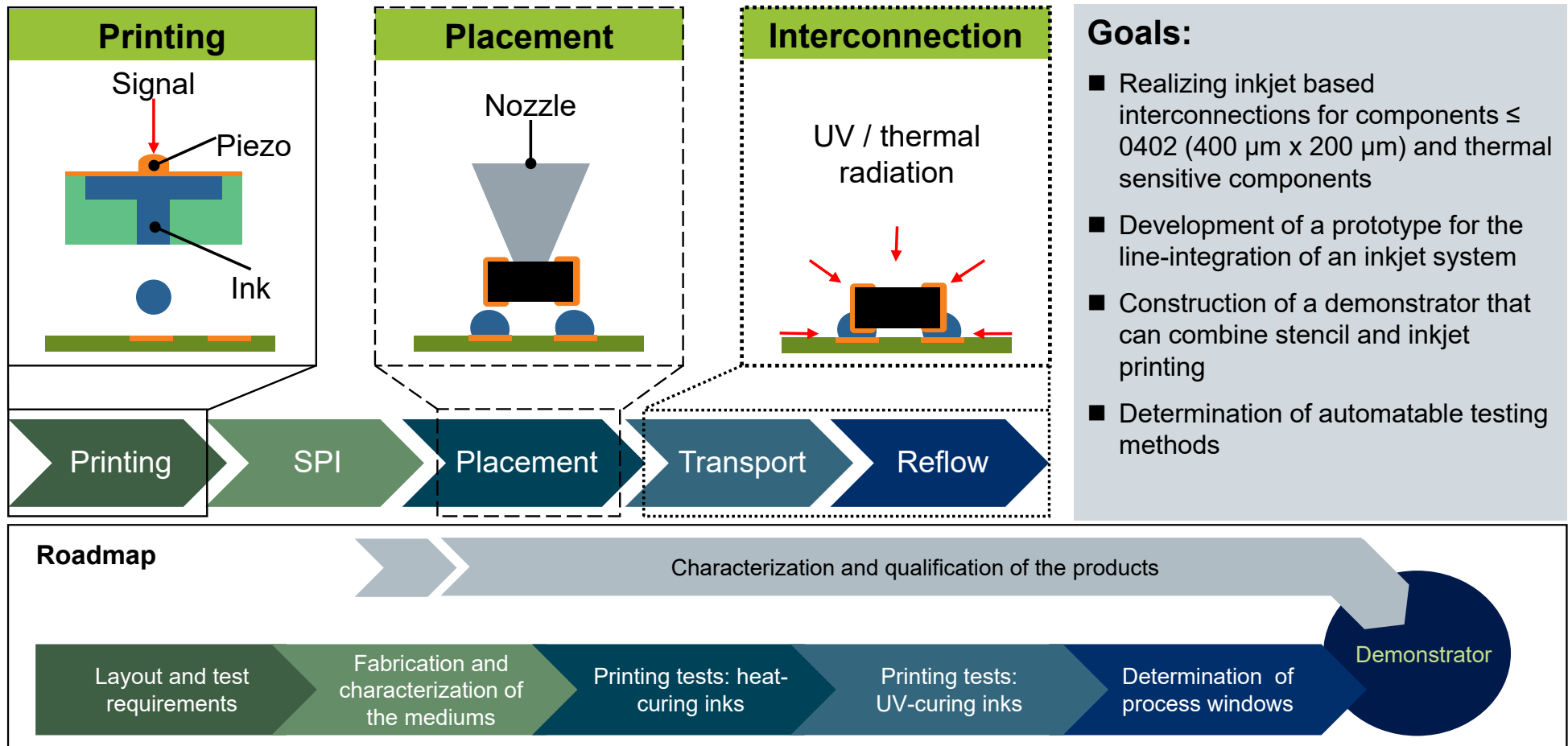
- Real time adjustment and monitoring of process and machine parameters
- Cross-line and transferable AI applications



Following the example of CATENA-X, FAPS is developing the platform EMS-X for the collaborative utilization of data in electronics production.



**FAPS investigates the use of inkjet printing to apply conductive inks for interconnections if conventional technologies reach their limits.**



The institute FAPS investigates various additive manufacturing techniques for structuring 3D printed circuit carriers.

### Laser Direct Structuring®



- Activation of additive through laser radiation
- Generation of micro-rough surfaces
- Chemical metallization to generate structures

Usage of one or more laser scanning units for targeted deflection of laser and irradiation of the surface

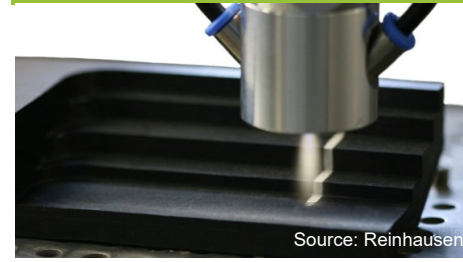
### Laser Powder Bed Fusion



- Powder based additive manufacturing
- Selective melting of the powder to generate structures
- Flexible geometries

Usage of one or more laser scanning units for targeted deflection of laser and irradiation of the surface and powder

### Plasma Powder Coating



- Additive metallization
- Flexible geometries
- Continuous conveying and application of the coating powder

Production of structures by relative movement of nozzle to substrate or substrate to nozzle.

### 5-Axis Printed Electronics

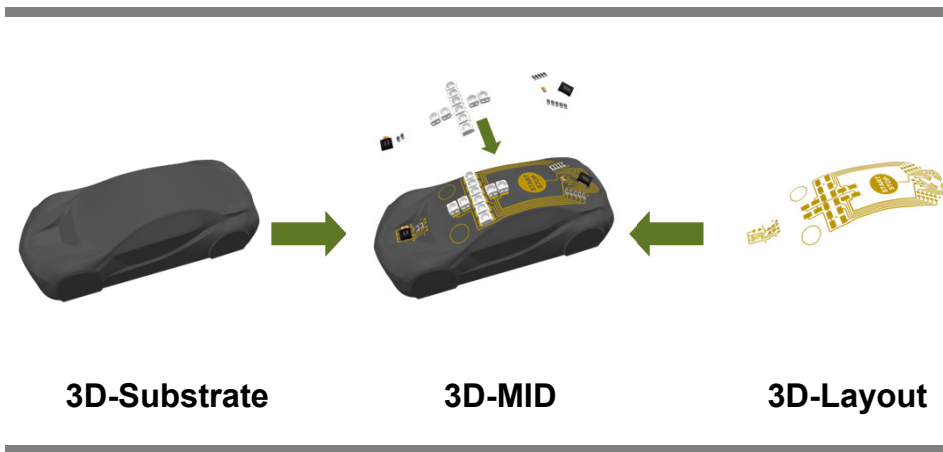


- Printing technologies for applying functional inks
- Flexible and fine structures
- Miniaturized 3D-Assemblies

Production of structures by relative movement of nozzle to substrate or substrate to nozzle.

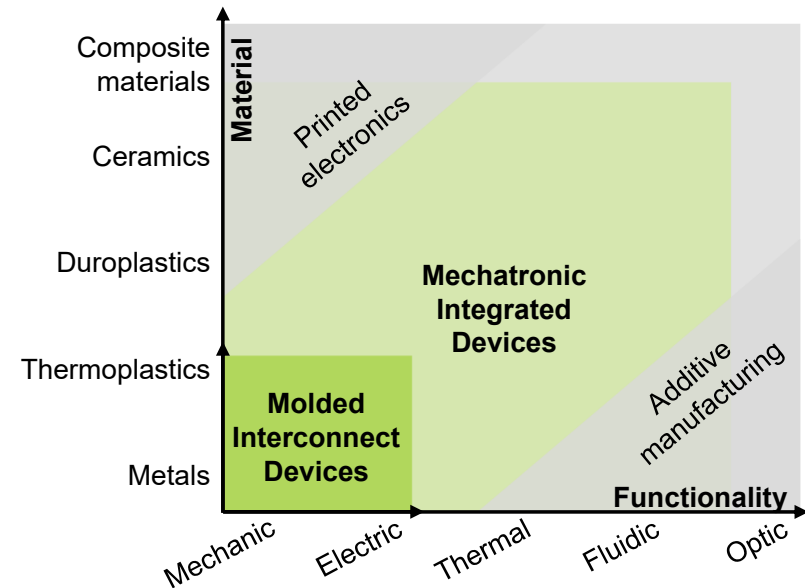
## MID – from Molded Interconnect Devices to Mechatronic Integrated Devices.

### MID-basic principle



### Molded Interconnect Devices

- 3D-MID are spatial *injection molded* parts with integrated conductor tracks.
- The technology allows the combination of *mechanic* (injection molding) and *electric/ electronic* (selective metallization) functionalities in one device.



### Mechatronic Integrated Devices

- 3D-MID are mechatronically functionalized spatial parts.
- The technology allows the combination of *mechanic, electric/ electronic, thermal, fluidic and optic* functionalities in one device.

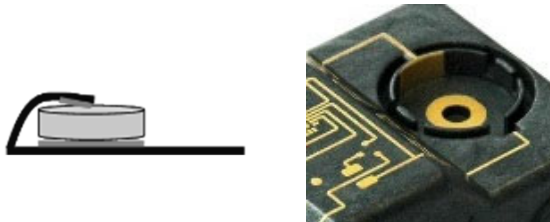


The manifold integration capabilities of the MID technology offer big potentials for innovative product solutions.

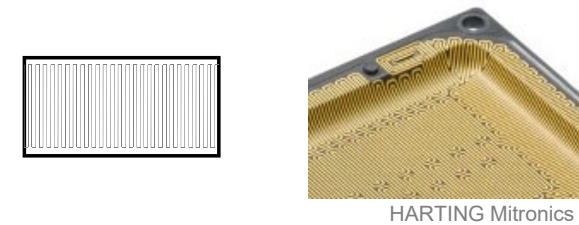
**Antennas**



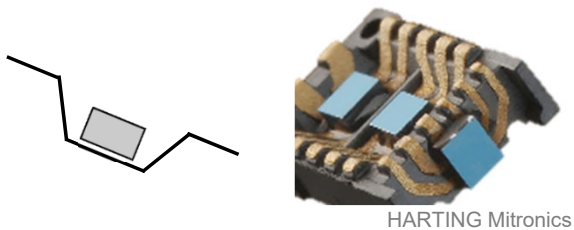
**Mounting elements**



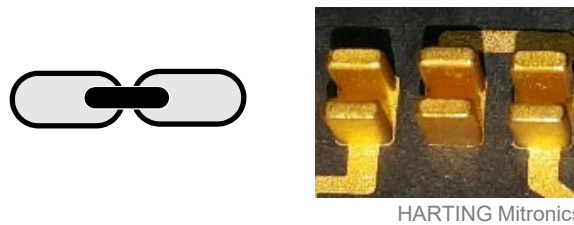
**Shielding / Security structures**



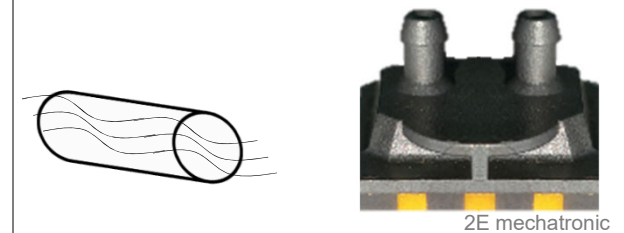
**Orientation of components**



**Contacting elements**



**Fluid channels**



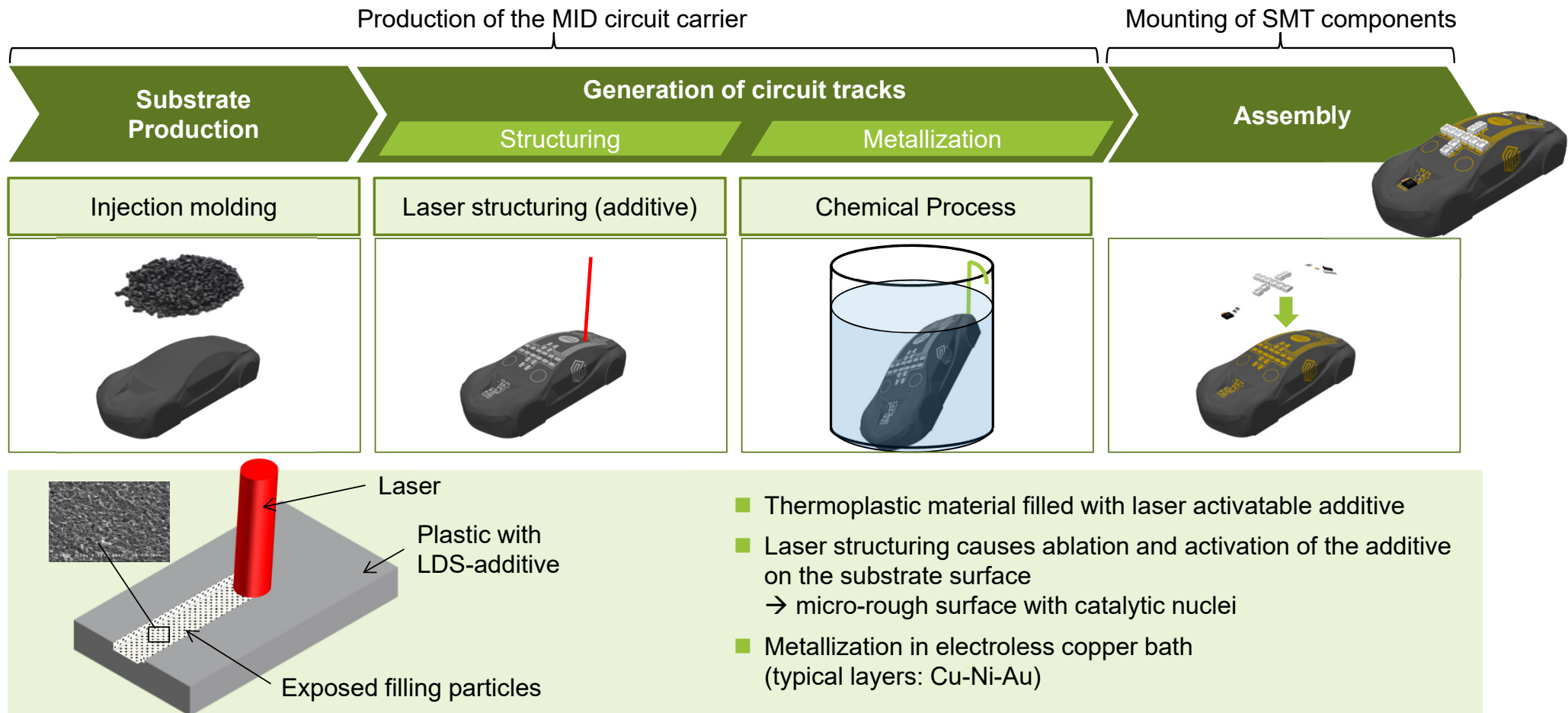
Design freedom

Reduction of  
components

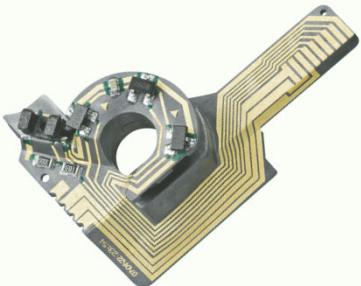
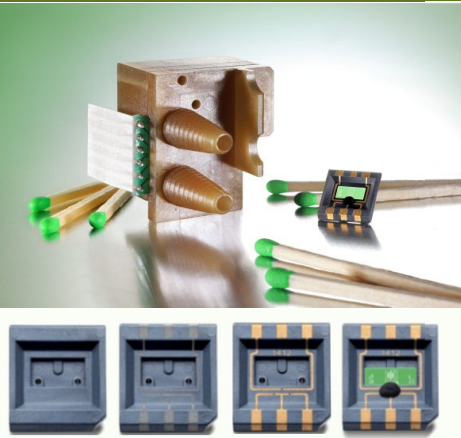
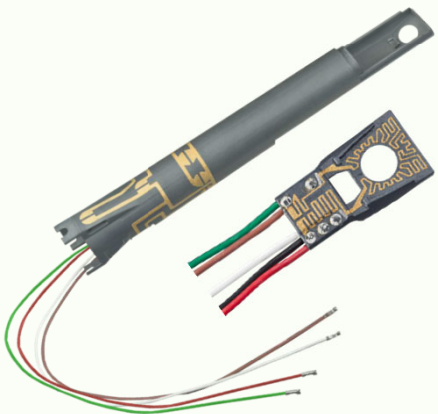
Increased functional  
density

Weight reduction

The classical process chain for manufacturing MID by Laser Direct Structuring (LDS) consists of injection molding, laser structuring and chemical metallization.



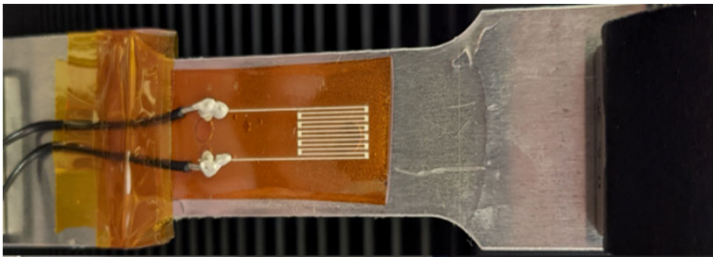
Many examples of successful LDS-based serial applications prove the wide application field in different industries.

| Adaptive Cruise Control                                                                                                                                                                                 | Lighting module                                                                                                                                                                         | Flow sensor                                                                                                                                                                    | Caries diagnosis tool                                                                                                                                                                         |
|---------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|-----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|--------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|-----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|
|                                                                                                                        |                                                                                                       |                                                                                             |                                                                                                            |
| <b>Industry:</b> Automotive<br><b>Technology:</b> LDS<br><b>Manufacturer:</b> HARTING Mitronics / 2E mechatronic<br><b>User:</b> Continental<br><b>Start:</b> 2010<br><b>Quantity:</b> ca. 800.000 p.a. | <b>Industry:</b> Industry automation<br><b>Technology :</b> LDS<br><b>Manufacturer:</b> HARTING Mitronics<br><b>User:</b> SICK<br><b>Start:</b> 2007<br><b>Quantity:</b> ca. 5.000 p.a. | <b>Industry:</b> Climate technology<br><b>Technology:</b> LDS<br><b>Manufacturer:</b> 2E mechatronic<br><b>User:</b><br><b>Start:</b> 2012<br><b>Quantity:</b> ca. 25.000 p.a. | <b>Industry:</b> Medical technology<br><b>Technology :</b> LDS<br><b>Manufacturer:</b> HARTING Mitronics<br><b>User:</b> KaVo Dental<br><b>Start:</b> 2013<br><b>Quantity:</b> ca. 2.500 p.a. |

(Sources: HARTING Mitronics, Continental, 2E mechatronic)

## The combination of printed electronics, additive manufacturing and AVT technologies of discrete electronics serves to create mechatronically integrated assemblies.

Printing of strain gauge elements



Production of complete mechatronic products by one machine



FDM

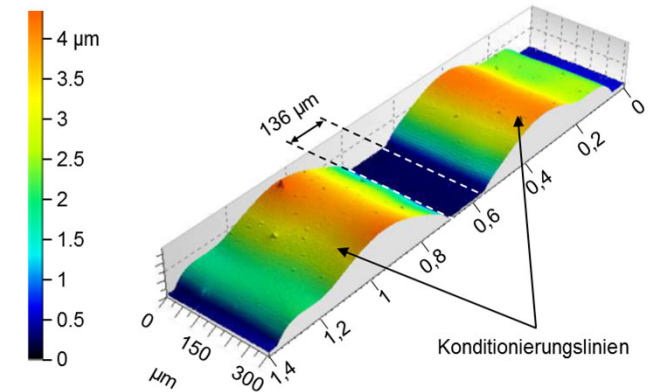
Piezojet

SMT

### 3D Printed Electronics

- Printing technologies for contactless application of functional inks and pastes (several millimetres working distance)
- Electrical and optical signals
- Printing of
  - Conductor tracks (20µm - 1mm)
  - Resistors
  - Capacitors
  - Sensors
  - Fibre optic cables
  - Antennas
  - Contacting of SMTs
- Light sintering system for curing the printed structures

Customised production of polymer optical fibres by flexo and aerosol jet printing



Development of methods and guidelines for the print production of HF applications





## Additive Manufacturing of ceramic materials in combination with printed conductive inks leads to flexible production of functional 3D electronic assemblies in harsh environments.

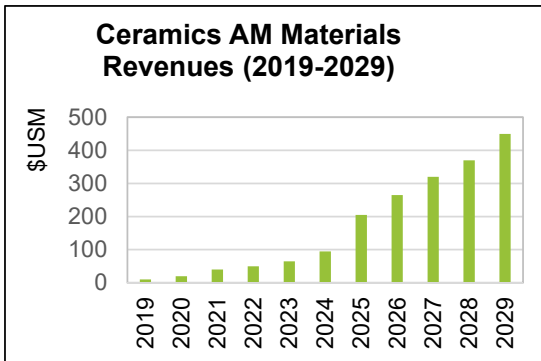


Fig. 01: Prediction of Ceramics AM Materials Sales,  
Source: Smartech Analysis (2019)

Fused  
Filament  
Fabrication  
(FFF)

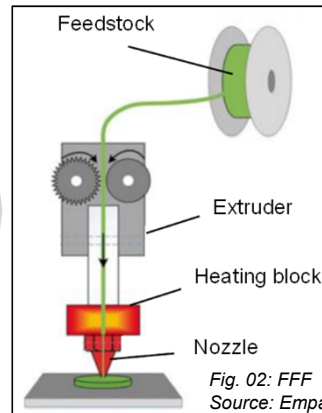


Fig. 02: FFF  
Source: Empa

Ceramic  
green body  
production  
through  
parameter  
studies

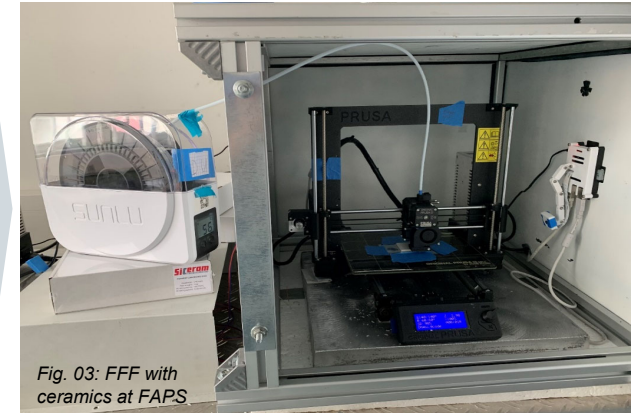


Fig. 03: FFF with  
ceramics at FAPS

Using piezo-jet technology,  
conductive structures can  
be printed flexibly on  
ceramic substrates

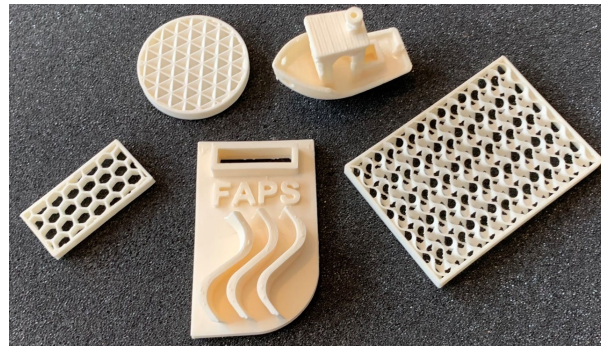


Fig. 05: Ceramic specimens with complex 3D shape, printed with FFF,  
debinded and sintered at FAPS

After sintering in high  
temperature furnace,  
complex 3D ceramic  
bodies are ready for  
metallization



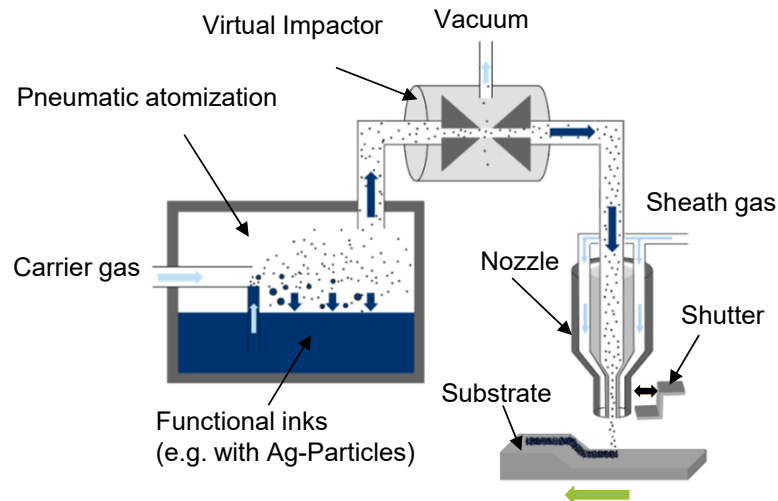
Fig. 04: Bodies debinded  
in Aceton bath at FAPS

Debinding  
by chemical  
and thermal  
processes

## Digital printing processes allow the printing of 3D objects with electrically functional inks.

### Aerosol Jet

- Serial contactless printing process
- Structures smaller than 10  $\mu\text{m}$  up to 10 mm with varying nozzle geometries realizable
- Large working distance through elongated focus of aerosol beam
- Wide spectrum of material properties of the used medium
- Printing of functional elements like conductive patterns, resistors, isolation layers, capacitors, etc.

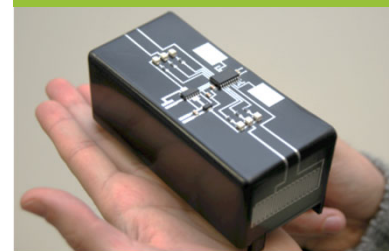


Aerosol Jet printing on an egg with a 5-axis motion system



Contact Pads - Side 2  
4 Axis: X-Y-Z + B Axis Rotation

Printed circuit layout with capacitive sensors for 3D-MID



Printed antennas for mobile applications

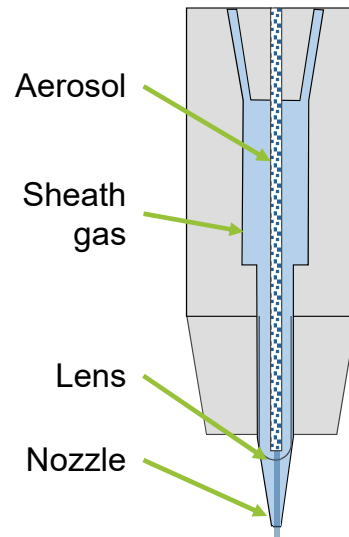


Source: Neotech

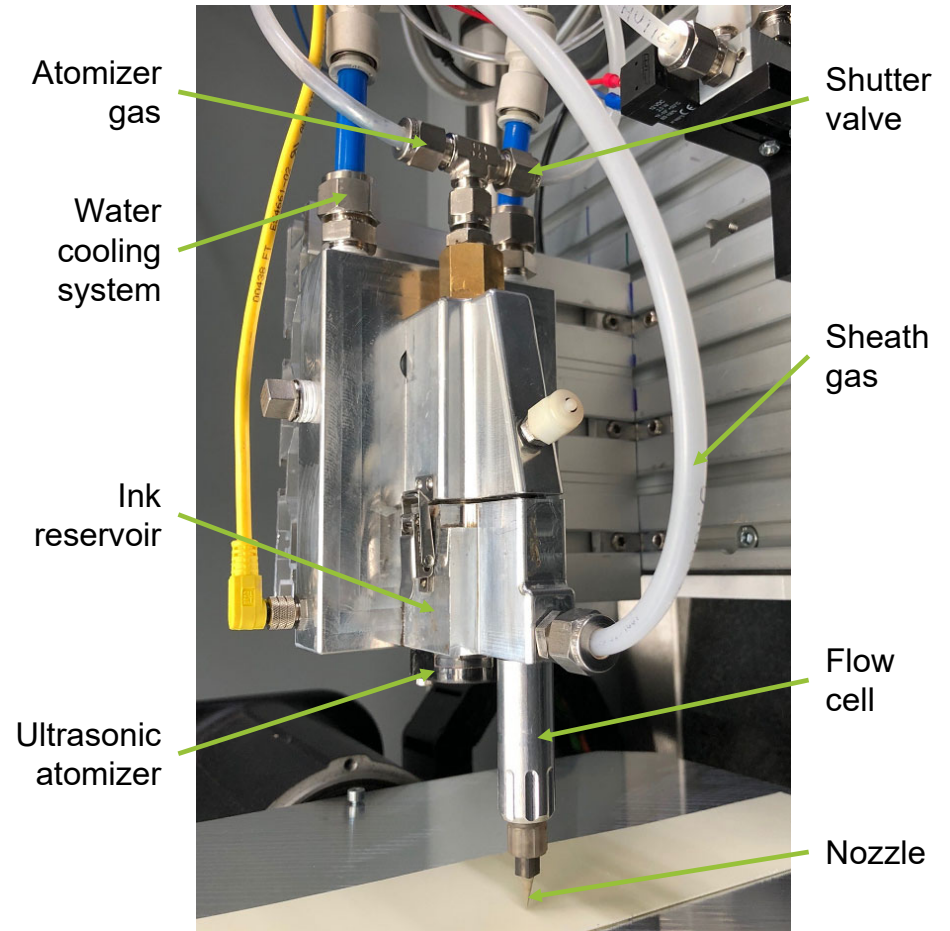
## The Nanojet process enables the generation of fine structures which are required for high-frequency applications.

### Nanojet

- Simplified system compared to Aerosol Jet (no bubblers, heaters or solvent add-Overview)
- Aerosol generation by ultrasonic atomization of functional ink
- Aerodynamic lenses focus the aerosol
- Changeable nozzles allow line widths from 20  $\mu\text{m}$  to 1 mm
- Particle focusing in flow cell by lens and sheath gas
- Ink viscosities < 20 mPas



Helix antenna

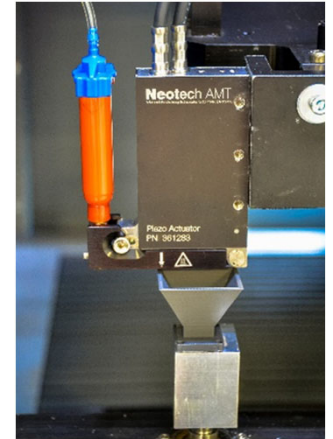
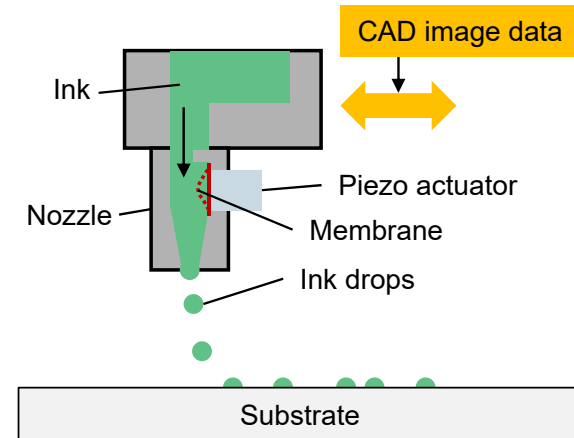


| Process parameter   | Value             |
|---------------------|-------------------|
| Atomizer voltage    | 28 V              |
| Chiller temperature | 22°C              |
| Aerosol flow rate   | 8 sccm            |
| Sheath flow rate    | 50 sccm           |
| Lens diameter       | 750 $\mu\text{m}$ |
| Nozzle diameter     | 233 $\mu\text{m}$ |

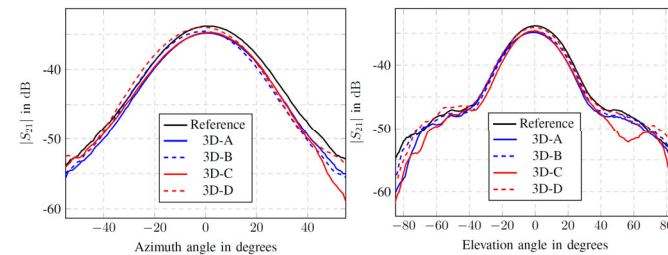
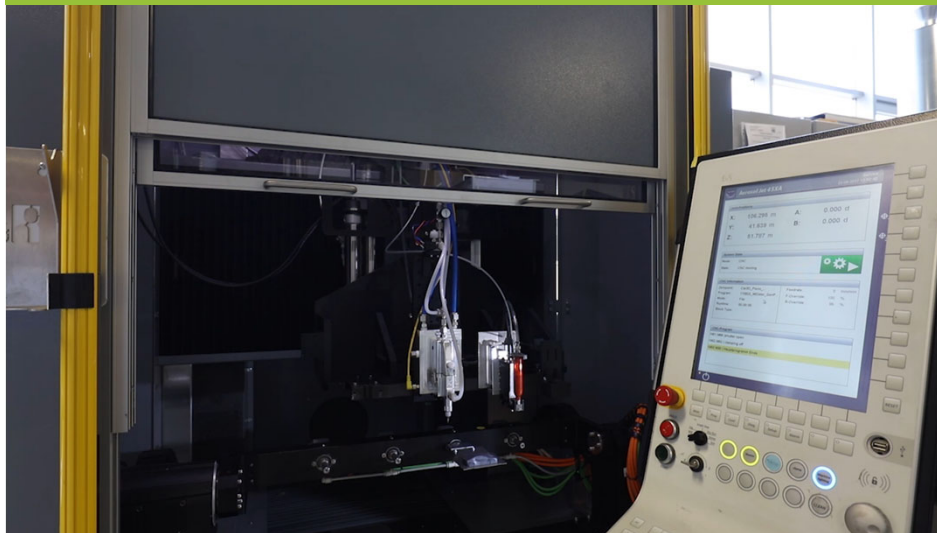
## The Piezojet printhead can process a wide range of ink viscosities with a high stand-off distance.

### Piezojet Drop-on-Demand:

- Functional ink is passed from the reservoir into the nozzle
- Piezo actuator is deformed by a voltage signal
- Pressure pulse ejects an ink drop onto the substrate
- Printhead is moved according to CAD image data
- Viscosities up to 200,000 mPas and 250  $\mu\text{m}$  – 1 mm line widths



Printing on a MID demonstrator with a 5-axis motion system with Piezojet and Nanojet



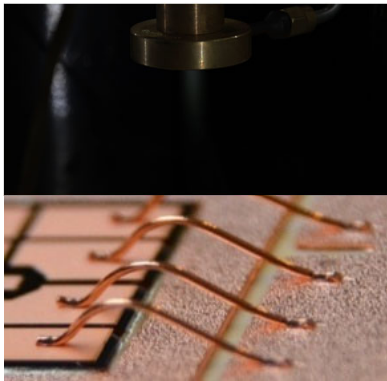
Additive horn antenna



# Innovative manufacturing technologies for assembly and connection technology significantly influence the performance of electronic modules.

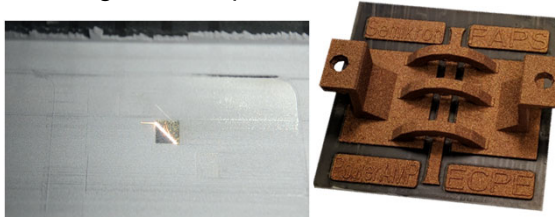
## Top-Level Interconnection

- Increase of power density through optimized bondlayout
- Increased efficiency through the use of copper
- Development of chip-buffer systems



## Integration of additive manufacturing

- Integration of optimized heat sinks by addressing hot-spots
- Production substrates in small lot sizes through flexible processes

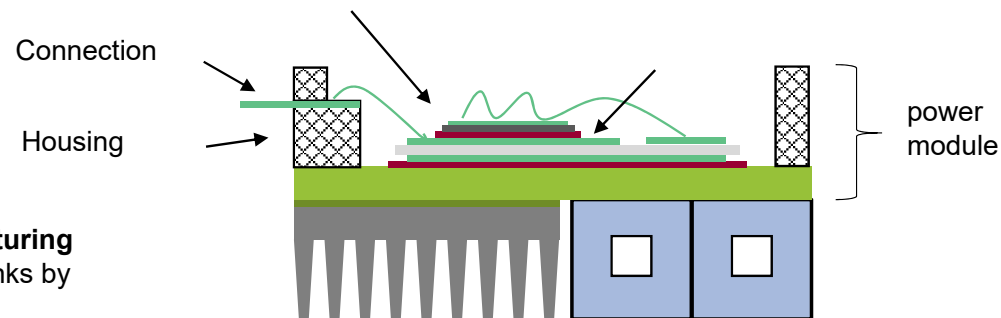


### Top-Level Interconnection

- Aluminium wires
- Copper wires
- Chip-Buffer Systems

### Bottom-Level Interconnection

- Silver pasts
- Copper pasts



### Heat sink

- Active/passive
- Additively manufactured

## Bottom-Level Interconnection

- Qualification of Ag und Cu Pasts
- Packaging optimization via transient liquid phase soldering

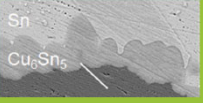
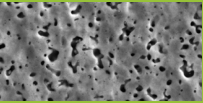
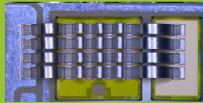
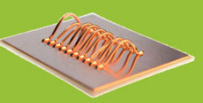
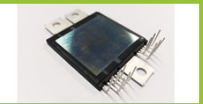


## Testing & Qualification

- Definition of effect-equivalent testing methods
- Active & passive lifetime testing e.g. Power cycling, H3TRB, Thermo cycling



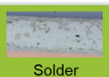
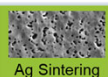
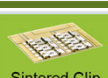
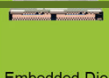
**Advances in power electronics packaging enable increased reliability and power density.**

|                                     |                                                                                                                       |                                                                                                                                |                                                                                                                               |                                                                                                                              |                                                                                                                              |                                                                                                                                     |
|-------------------------------------|-----------------------------------------------------------------------------------------------------------------------|--------------------------------------------------------------------------------------------------------------------------------|-------------------------------------------------------------------------------------------------------------------------------|------------------------------------------------------------------------------------------------------------------------------|------------------------------------------------------------------------------------------------------------------------------|-------------------------------------------------------------------------------------------------------------------------------------|
| Substrate                           | <br>Leadframe<br>source: Schunk      | <br>DCB<br>source: Rogers                     | <br>Thick print<br>source: Heraeus         | <br>AMB<br>source: Heraeus                | <br>Double sided                          | <br>Integrated substrate                         |
| Interconnection<br>Chip Bottom-Side | <br>Solder<br>source: BO             | <br>TLPS / TLPB<br>source: Syed-Khaja / FAPS  | <br>Ag Sintering<br>by M $\mu$             | <br>Cu Sintering<br>source: Vitesco → AHn |                                                                                                                              | <br>Embedded Die<br>source: Schweizer Electronic |
| Interconnection<br>Chip Top-Side    | <br>Al Wire Bond                     | <br>Al Ribbon Bond<br>Source Changed - MSr    | <br>AlCu Wire Bond<br>source: Heraeus → CH | <br>Cu Wire Bond                          | <br>Sintered Clip<br>Source Changed - MSr |                                                                                                                                     |
| Encapsulation                       | <br>Soft Potting<br>source: Wacker | <br>Hard Potting<br>source: Sprenger / FAPS | <br>Transfer Mold<br>by M $\mu$          |                                                                                                                              |                                                                                                                              |                                                                                                                                     |

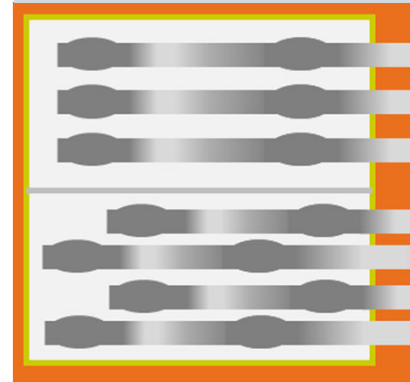
Power density



## In the field of Die Top-Side Interconnection Copper Wire Bonding, Bond Layout Optimization and Selective Metallization by Plasma Spray is investigated at FAPS.

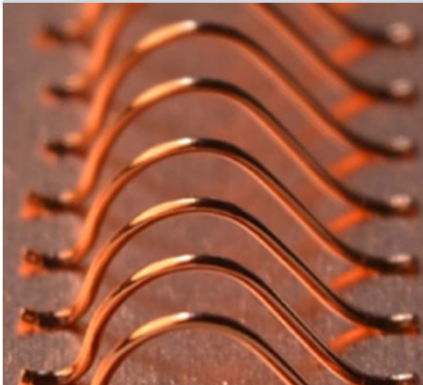
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| Substrate                        | <br>Leadframe<br><small>source: Schunk</small>    | <br>DCB<br><small>source: Rogers</small>                     | <br>Thick print<br><small>source: Heraeus</small>       | <br>AMB<br><small>source: Heraeus</small>             | <br>Double sided                                                   | <br>Integrated substrate                                            |
| Interconnection Chip Bottom-Side | <br>Solder<br><small>source: BO</small>           | <br>TLPS / TLPB<br><small>source: Syed-Khaja / FAPS</small>  | <br>Ag Sintering<br><small>by Mu</small>                | <br>Cu Sintering<br><small>source: Viesco AGH</small> |                                                                                                                                                     |                                                                                                                                                       |
| Interconnection Chip Top-Side    | <br>Al Wire Bond                                  | <br>Al Ribbon Bond<br><small>source: Heraeus M&amp;P</small> | <br>AlCu Wire Bond<br><small>source: Heraeus GH</small> | <br>Cu Wire Bond                                      | <br>Sintered Clip<br><small>source: Fraunhofer IPA M&amp;P</small> | <br>Embedded Die<br><small>source: Schwaiblmair Electronics</small> |
| Encapsulation                    | <br>Soft Potting<br><small>source: Wacker</small> | <br>Hard Potting<br><small>source: Springer / FAPS</small>   | <br>Transfer Mold<br><small>by Mu</small>               |                                                                                                                                        |                                                                                                                                                     |                                                                                                                                                       |

### Optimized Bond Layout



- Increase in power cycling capabilities without changes to existing production facilities
- Design-Guide for wire bond layouts to estimate reliability during development of new power modules
- Improved correlation between simulation data and application

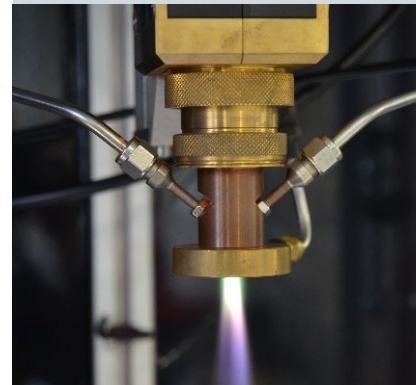
### Cu Wire Bonding



Compared to Al wire bonding:

- Better CTE match at bond interface
- Improved thermal cycling stability
- Lower electrical resistance
- Higher thermal conductivity

### Plasma based Cu Coating

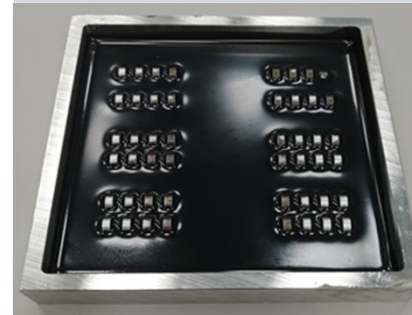


- Freedom of design
- Flexible metallization of various substrate materials and semiconductors, allowing for Cu wire bonding
- Generation of high conductive circuit path (up to 60% of Cu)
- High-Temperature applications

Other investigated technologies are additive manufacturing of metal-ceramic-substrates, transient liquid phase soldering and advanced encapsulation techniques and materials.

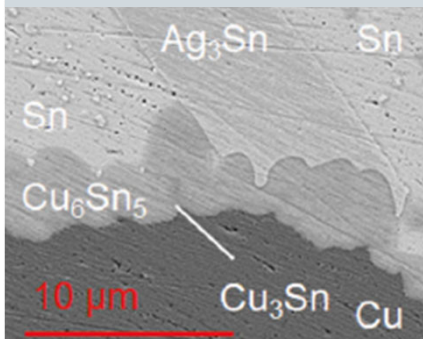
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|-------------------------------------|-----------------------------------------------|----------------------------------------------------------|-----------------------------------------------------|---------------------------------------------------|--------------------------------------------------------|-----------------------------------------------------------|
| Substrate                           | Leadframe<br><small>source: Schunk</small>    | DCB<br><small>source: Rogers</small>                     | Thick print<br><small>source: Heraeus</small>       | AMB<br><small>source: Heraeus</small>             | Double sided                                           | Integrated substrate                                      |
| Interconnection<br>Chip Bottom-Side | Solder<br><small>source: BO</small>           | TLPS / TLPB<br><small>source: Syed-Khaja / FAPS</small>  | Ag Sintering<br><small>by Mu</small>                | Cu Sintering<br><small>source: Viesco AGH</small> |                                                        |                                                           |
| Interconnection<br>Chip Top-Side    | Al Wire Bond                                  | Al Ribbon Bond<br><small>source: Heraeus M&amp;P</small> | AlCu Wire Bond<br><small>source: Heraeus GH</small> | Cu Wire Bond                                      | Sintered Clip<br><small>source: Fraunhofer IPA</small> | Embedded Die<br><small>source: Schmalz Electronic</small> |
| Encapsulation                       | Soft Potting<br><small>source: Wacker</small> | Hard Potting<br><small>source: Sprenger / FAPS</small>   | Transfer Mold<br><small>by Mu</small>               |                                                   |                                                        |                                                           |

Hard encapsulation by potting or transfer molding



- Reliability enhancement by replacement of soft encapsulation with hard encapsulant
- Advanced encapsulants for wide band gap temperature operation range
- Cost reduction potential by integration of function into the molded structures

High temperature interconnects



- Silversintering, Cu-Sintering  
Compared to Sn-soldering:

- Better thermal performance
- Higher homologous temperature, higher operational temperature

Compared to sintering:

- Less complex tooling

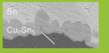
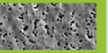
SLM-based metal-ceramic substrates and heatsinks



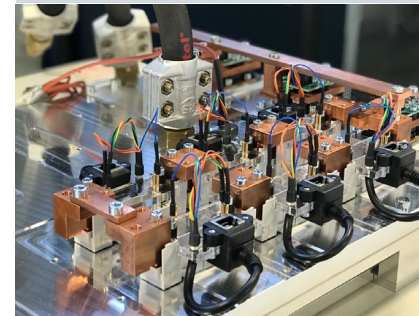
- Integration of cooling structures directly into the substrate (integrated substrate)
- Design freedom, flexible adaption of layer stack up



## Accelerated lifetime testing allows for reliability assessment of different power electronic packaging technologies.

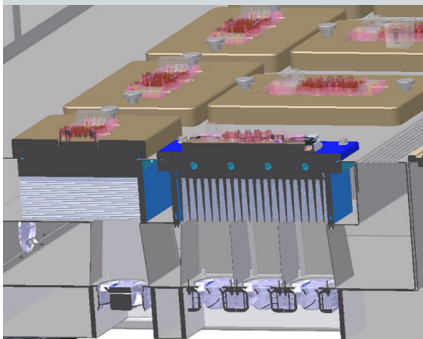
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|----------------------------------|------------------------------------------------------------------------------------------------------------------------------------|----------------------------------------------------------------------------------------------------------------------------------------------|------------------------------------------------------------------------------------------------------------------------------------------|----------------------------------------------------------------------------------------------------------------------------------------|-------------------------------------------------------------------------------------------------------------------------------------------------|---------------------------------------------------------------------------------------------------------------------------------------------------|
| Substrate                        | <br>Leadframe<br><small>source: Schunk</small>    | <br>DCB<br><small>source: Rogers</small>                    | <br>Thick print<br><small>source: Heraeus</small>       | <br>AMB<br><small>source: Heraeus</small>             | <br>Double sided                                               | <br>Integrated substrate                                        |
| Interconnection Chip Bottom-Side | <br>Solder<br><small>source: BO</small>           | <br>TLPS / TLPB<br><small>source: Syed-Khaja / FAPS</small> | <br>Ag Sintering<br><small>by Mu</small>                | <br>Cu Sintering<br><small>source: Viesco AMH</small> |                                                                                                                                                 |                                                                                                                                                   |
| Interconnection Chip Top-Side    | <br>Al Wire Bond                                  | <br>Al Ribbon Bond<br><small>source: Heraeus MSR</small>    | <br>AlCu Wire Bond<br><small>source: Heraeus GH</small> | <br>Cu Wire Bond                                      | <br>Sintered Clip<br><small>source: Fraunhofer IZB MPE</small> | <br>Embedded Die<br><small>source: Schweizer Electronic</small> |
| Encapsulation                    | <br>Soft Potting<br><small>source: Wacker</small> | <br>Hard Potting<br><small>source: Sprenger / FAPS</small>  | <br>Transfer Mold<br><small>by Mu</small>               |                                                                                                                                        |                                                                                                                                                 |                                                                                                                                                   |

### Active Power Cycling



- Accelerated lifetime test for power electronic modules
- Thermomechanical stress distribution comparable to application
- Evaluation of reliability of chip and substrate interconnections

### H3TRB



- Application of field voltage of max. 3.3 kV
- Indication of failure mechanisms by leakage current
- Simultaneous test of 60 DUTs
- Integrated Curve Tracer

### Environmental Testing



- Temperature shock testing (air to air)
- High temperature storage
- Vibration test
- Salt spray test

**Cross sections combined with focused ion beam and high resolution electron microscopy or mechanicals tests allow for in-depth analysis of the interconnection technologies.**

|                                     |                                |                                          |                                      |                                    |                                             |                                              |
|-------------------------------------|--------------------------------|------------------------------------------|--------------------------------------|------------------------------------|---------------------------------------------|----------------------------------------------|
| Substrate                           | Leadframe<br>source: Schunk    | DCB<br>source: Rogers                    | Thick print<br>source: Heraeus       | AMB<br>source: Heraeus             | Double sided                                | Integrated substrate                         |
| Interconnection<br>Chip Bottom-Side | Solder<br>source: BO           | TLPS / TLPB<br>source: Syed-Khaja / FAPS | Ag Sintering<br>by Mu                | Cu Sintering<br>source: Viesco AMH |                                             |                                              |
| Interconnection<br>Chip Top-Side    | Al Wire Bond                   | Al Ribbon Bond<br>source: Heraeus MSR    | AlCu Wire Bond<br>source: Heraeus GH | Cu Wire Bond                       | Sintered Clip<br>source: Fraunhofer IZB MSc | Embedded Die<br>source: Schweizer Electronic |
| Encapsulation                       | Soft Potting<br>source: Wacker | Hard Potting<br>source: Sprenger / FAPS  | Transfer Mold<br>by Mu               |                                    |                                             |                                              |

### Metallography



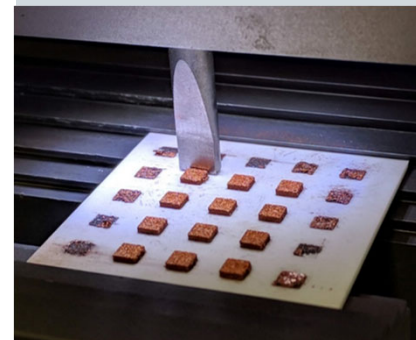
- Cross-section of micrographs
- Sawing, Embedding, Etching, Grinding, Polishing
- Microscope Inspection

### SEM



- Detectors, manipulators and possible analysis
  - EDX
  - EBSD
  - Raman-Spectroscopy
  - Plasma-FIB

### Mechanical Testing



- Bending Tests
- Shear Testing
- Hot-Pin-Pull-Test





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**Friedrich-Alexander-Universität**  
Technische Fakultät

# THANK YOU